

JAN 24 2002

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Bailey III, et al.

Attorney Docket No.: LAM1P128/P0561

Application No.: 09/440,794

Examiner: Anderson, M.

Filed: November 15, 1999

Group: 1765

Title: MATERIALS AND GAS CHEMISTRIES
FOR PROCESSING SYSTEMS

COPY OF PAPERS
ORIGINALLY FILED

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Commissioner for Patents, Washington, DC 20231 on December 10, 2001.

Signed:

Lara M. Nelson

AMENDMENT TRANSMITTAL

Commissioner for Patents
Washington, DC 20231

RECEIVED
FEB - 4 2002
TC 1700

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

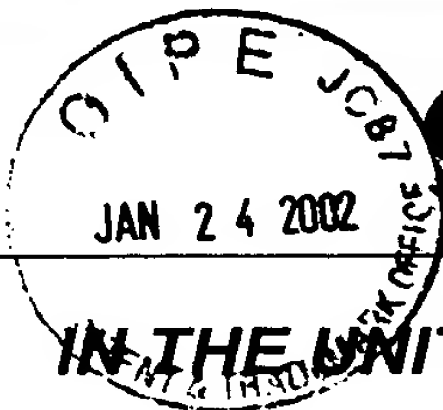
	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	15	MINUS	48	00	x 9 =	x 18 =
Independent Claims	01	MINUS	04	00	x 42 =	x 84 =
Multiple Dependent Claim Present and Fee Not Previously Paid					\$140.00	\$280.00
Total					\$	\$

- ☐ Applicant(s) hereby petition for a _____ month extension(s) of time to respond to the aforementioned Office Action.
- ☒ Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 500388.
- ☐ Enclosed is our Check No. _____ in the amount of \$_____ to cover the additional claim fee and/or extension of time fees.
- ☒ Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 500388 (Order No. LAM1P128).

Respectfully submitted,
BEYER-WEAVER & THOMAS, LLP

Ramin Mahboubian
Reg. No. 44,890

P.O. Box 778
Berkeley, CA 94704-0778



#9/A
PATENT
3/6/02

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Lara M. Nelson

Printed Name: Lara M. Nelson

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AMENDMENT A

Commissioner for Patents
Washington, D.C. 20231

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TC 1700**

Dear Sir:

In response to the Office Action dated September 10, 2001, please amend the above-identified patent application as follows:

IN THE CLAIMS:

Please **CANCEL** claims 1-30 and 46-48 without prejudice.

Please **AMEND** claims 31, 33, 34, 35, 36 and 37 as follows.

31. (Once Amended) A method for controlling processing uniformity while processing a substrate using a plasma-enhanced process, comprising: